

DOCKET No.: 50099-184

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masato FUJINAGA

Serial No.:

Group Art Unit:

Filed: October 16, 2001

Examiner:

For: HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

**CLAIM OF PRIORITY AND
TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT**

Commissioner for Patents
Washington, DC 20231

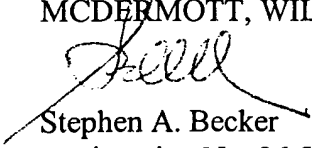
Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claims the priority of:
Japanese Patent Application No. 2000-349807, filed November 16, 2000

cited in the Declaration of the present application. A certified copy is submitted herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:mlw
Date: October 16, 2001
Facsimile: (202) 756-8087

RECEIVED
MAR 17 2003
TECHNOLOGY CENTER-2800



50074-134
Masato Fujin
October 16, 20

日 本 国 特 許 庁

PATENT OFFICE
JAPANESE GOVERNMENT

McDermott, Will & E

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
th this Office.

出 願 年 月 日

Date of Application:

2000年11月16日

出 願 番 号

Application Number:

特願2000-349807

願 人

Applicant(s):

三菱電機株式会社

RECEIVED
MAR 17 2003
TECHNOLOGY CENTER 2800

2000年12月 8日

特許庁長官
Commissioner,
Patent Office

及川耕造

